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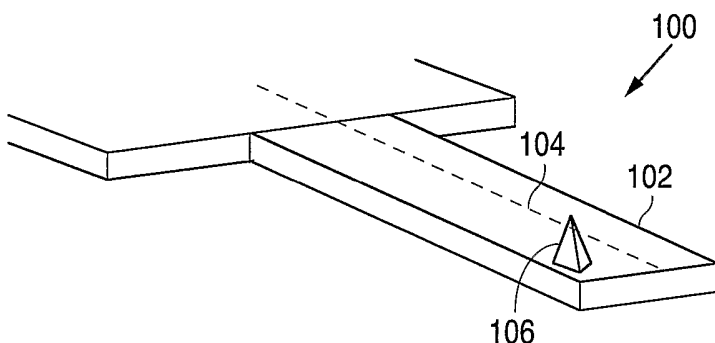
(43) International Publication Date
9 February 2006 (09.02.2006)

PCT

(10) International Publication Number
WO 2006/014542 A1

- (51) International Patent Classification⁷: **G12B 21/02**, 21/08
- (74) Agent: **COOK, Carmen, C.**; Patent Law Group LLP, 2635 North First Street, Suite 223, San Jose, CA 95134 (US).
- (21) International Application Number: PCT/US2005/024098
- (81) Designated States (*unless otherwise indicated, for every kind of national protection available*): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI, GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KM, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NA, NG, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SM, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM, ZW.
- (22) International Filing Date: 7 July 2005 (07.07.2005)
- (25) Filing Language: English
- (26) Publication Language: English
- (30) Priority Data: 10/887,608 8 July 2004 (08.07.2004) US
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- (84) Designated States (*unless otherwise indicated, for every kind of regional protection available*): ARIPO (BW, GH, GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IS, IT, LT, LU, LV, MC, NL, PL, PT, RO, SE, SI, SK, TR), OAPI (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).
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- Published:
— with international search report
- For two-letter codes and other abbreviations, refer to the "Guidance Notes on Codes and Abbreviations" appearing at the beginning of each regular issue of the PCT Gazette.*

(54) Title: TORSIONAL HARMONIC CANTILEVERS FOR DETECTION OF HIGH FREQUENCY FORCE COMPONENTS IN ATOMIC FORCE MICROSCOPY



(57) Abstract: A cantilever for the use in atomic force microscopy includes a cantilever arm having a fixed end being attached to a base member and a free end where the cantilever arm has a first shape and an axis of torsion associated with the first shape, and a probe tip projecting from the cantilever arm near the free end where the probe tip is positioned in an offset displacement from the axis of torsion. Alternately, the cantilever arm has a first shape selected to tune a torsional resonance frequency of a selected torsional mode or the fundamental flexural resonance frequency of the fundamental

mode so that the torsional resonance frequency and the fundamental flexural resonance frequency has an integer ratio. In this manner, the torsional motion of the torsional harmonic cantilever at that harmonic frequency will be largely enhanced by the corresponding torsional resonance.

**Torsional Harmonic Cantilevers For Detection Of High
Frequency Force Components In Atomic Force Microscopy**

5 FIELD OF THE INVENTION

[0001] The invention relates to cantilevers and imaging methods using the cantilevers and, in particular, to cantilevers for detecting high frequency force components and imaging methods using the same.

10 DESCRIPTION OF THE RELATED ART

[0002] Scanning Probe Microscopy (SPM) refers to the class of instruments and imaging methods where a probe, typically of very small dimensions, is scanned relative to a sample surface for providing a microscopic analysis of the
15 topographical features or material properties of the sample surface. A variety of SPM is Atomic Force Microscopy (AFM), also referred to as Scanning Force Microscopy (SFM), where a flexible cantilever with a tip is used to scan the sample surface.

20 [0003] An atomic force microscope (AFM) has proven to be an exceptionally useful tool for mapping the topography of surfaces at the nanoscale. In an AFM, a flexible cantilever with an atomically sharp tip is brought to the vicinity of a sample surface and the deflections of the cantilever as a
25 result of the attractive and repulsive forces between the tip and the sample are monitored while the cantilever is scanned across the surface. The cantilever can be in a contacting mode of operation where the tip is in constant contact with the sample surface. When continuous contact
30 between the tip and the sample is used, frictional forces between the tip and the sample often result in damages to

both the tip and the sample. Dynamic imaging techniques that do not require continuous tip-sample contact have also been introduced. In dynamic imaging modes, the tip is maintained at a short distance from the surface of the sample and makes intermittent contact with the sample surface. Among the various dynamic imaging techniques, tapping-mode atomic force microscopy (TM-AFM) has become the most widely used. In TM-AFM, the tip is vibrated at one of its resonance frequency in vicinity of the sample surface. Dynamic atomic force microscopy methods (such as TM-AFM) largely eliminate tip and sample damage and are therefore widely used in atomic force microscopy imaging.

[0004] In atomic force microscopy, the force interaction between the tip and sample surface depends on the material properties of the tip and the sample. Measurement of the tip-sample forces enables study of material properties and mapping of chemical composition variations across the sample surface. When the cantilever vibrates in the vicinity of a sample, tip-sample forces will have higher harmonic components that generate high frequency vibrations in the cantilever. These high frequency force components carry information about the tip-sample interaction. Imaging with these higher harmonics has been demonstrated and the result has shown good contrast based on material properties. Unfortunately, the vibration amplitudes of traditional AFM cantilevers at higher harmonics are too small for practical AFM imaging. Specifically, the signals at higher harmonics are 20-30 dB lower than the signal at the driving frequency of the cantilever. Thus, the resolution of imaging using the higher harmonics signals is severely limited.

[0005] Therefore, it is desirable to provide an apparatus or image method which can enable non-destructive measurement

of the high frequency tip-sample force components as result of the vibration of a cantilever near a sample surface.

SUMMARY OF THE INVENTION

[0006] According to one embodiment of the present invention, a cantilever for the use in atomic force microscopy includes a cantilever arm having a fixed end being attached to a base member and a free end where the cantilever arm has a first shape and an axis of torsion associated with the first shape, and a probe tip projecting from the cantilever arm near the free end where the probe tip is positioned in an offset displacement from the axis of torsion. In one embodiment, the probe tip is positioned at least about 2 μ m from the axis of torsion. In another embodiment, the probe tip is positioned away from the axis of torsion and near an outside edge of the cantilever arm.

[0007] In one embodiment, the cantilever arm has a first shape selected to tune a resonance frequency of a selected torsional mode or the fundamental flexural resonance frequency so that the torsional resonance frequency and the fundamental flexural resonance frequency has an integer ratio. In this manner, the torsional motion of the torsional harmonic cantilever at that harmonic frequency will be largely enhanced by the corresponding torsional resonance.

[0008] According to another aspect of the present invention, a method for measuring high frequency force of interaction between a tip of a cantilever and a sample includes providing a cantilever having a cantilever arm and a probe tip formed on a free end of the cantilever arm where the cantilever arm has a first shape and an axis of torsion associated with the first shape and the probe tip is positioned in an offset displacement from the axis of

torsion, vibrating the cantilever at or near the fundamental flexural resonance frequency with a predetermined oscillation amplitude, bringing the cantilever to the vicinity of the sample, tapping the surface of the sample repeatedly using the probe tip, and detecting changes in the amplitude or the phase of a high frequency vibration harmonic of the cantilever as the cantilever is deflected in response to features on the surface of the sample.

[0009] According to another aspect of the present invention, a method for measuring high frequency force of interaction between a tip of a cantilever and a sample includes providing a cantilever having a cantilever arm and a probe tip formed on a free end of the cantilever arm where the cantilever arm has a first shape and an axis of torsion associated with the first shape and the probe tip is positioned in an offset displacement from the axis of torsion, vibrating the cantilever at or near the fundamental flexural resonance frequency with a predetermined oscillation amplitude, bringing the cantilever to the vicinity of the sample, tapping the surface of the sample repeatedly using the probe tip, measuring torsional vibration harmonics of the cantilever motion as the cantilever is deflected in response to features on the surface of the sample, and reconstructing the time-resolved waveform of the tip sample forces using the measured torsional vibration harmonics.

[0010] The present invention is better understood upon consideration of the detailed description below and the accompanying drawings.

BRIEF DESCRIPTION OF THE DRAWINGS

[0011] Figure 1 is a generalized schematic diagram of a tapping-mode atomic force microscope.

5 [0012] Figure 2A is a perspective view of a cantilever according to one embodiment of the present invention.

[0013] Figure 2B is a top view of the cantilever of Figure 2A.

[0014] Figure 3 illustrates the mode shape of the torsional mode of the cantilever of Figures 2A and 2B.

10 [0015] Figure 4 illustrates a split photodetector and a deflection measurement technique using the photodetector for detecting flexural and torsional movements.

[0016] Figure 5 is a top view of a cantilever according to a first alternate embodiment of the present invention.

15 [0017] Figure 6 is the flexural vibration spectrum of the cantilever of Figure 5 while the cantilever is being tapped on a sample surface at the fundamental resonance frequency.

[0018] Figure 7 is the torsional vibration spectrum of the cantilever of Figure 5 while the cantilever is being
20 tapped on a sample surface at the fundamental resonance frequency.

[0019] Figure 8 is a top view of a cantilever according to a second alternate embodiment of the present invention.

[0020] Figure 9 is a top view of a cantilever according
25 to a third alternate embodiment of the present invention.

[0021] Figure 10 is a top view of a cantilever according to a fourth alternate embodiment of the present invention.

[0022] Figure 11 is a top view of a torsional harmonic cantilever according to one embodiment of the present invention.

[0023] Figure 12 is the torsional vibration spectrum of the torsional harmonic cantilever of Figure 11 while the cantilever is being tapped on a surface at the fundamental resonance frequency.

[0024] Figure 13 illustrates the mode shape of the torsional vibration of the torsional harmonic cantilever of Figure 11.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

[0025] In accordance with the principles of the present invention, a cantilever including a tip at the free end of the cantilever is configured to incorporate a geometric feature that amplifies signals associated with high frequency components of the tip-sample interaction force when the cantilever is vibrated near the surface of a sample. When the cantilever is applied in a scanning probe microscope, the cantilever forms a high bandwidth and highly sensitive mechanical system that enables the detection and measurement of signals associated with the high frequency force components of the non-linear tip-sample interaction. In one embodiment, the cantilever includes a cantilever arm and a tip at the free end of the cantilever arm that is positioned at an offset location from the axis of torsion of the cantilever arm. Placing the tip at the offset location from the axis of torsion enhances the torsional motions of the cantilever. As a result, signals related to a significant number of the high frequency force components of the tip-sample interaction force can be amplified to allow new imaging modalities or study of the material properties of the sample under test.

[0026] One useful application of the cantilever of the present invention is in a tapping-mode AFM where the cantilever can be used to study material properties of the sample. However, the cantilever of the present invention
5 can be applied in many other applications, both within scanning probe microscopy or beyond. In sum, the cantilever of the present invention can be applied when the high frequency tip-sample interaction force components are of interest.

10 [0027] Figure 1 is a generalized schematic diagram of a tapping-mode atomic force microscope. In the TM-AFM of Figure 1, the cantilever is vibrated at a frequency close to one of its flexural resonances, typically the fundamental resonance frequency, in the vicinity of the sample surface
15 so that the tip makes intermittent contacts (tapping) with the surface once in every oscillation period. During the scan across the surface, the amplitude of vibration is maintained at a constant value through a feedback loop that adjusts the height of the cantilever base. Specifically, a
20 light beam and a photodetector are used to measure the motion of the cantilever at the driving frequency. The feedback signal therefore reflects the topography of the surface. In Figure 1, the feedback loop includes an optical lever detection system and a feedback controller.

25 [0028] The cantilever of the present invention incorporates a geometric feature to realize amplification of high frequency force components of the interaction between a sample and the tip of the cantilever. The geometric feature can be implemented in various forms to accomplish the signal
30 amplification. According to one embodiment of the present invention, a cantilever includes a tip at the free end that is positioned at an offset location from the axis of torsion of the cantilever arm. The offset tip placement enhances

the torsional motion of the cantilever. Specifically, when the offset tip hits the sample surface, the interaction forces excite the torsional modes of the cantilever. In the present description, a cantilever with an offset tip
5 placement for enhancing torsional motion will be referred to as a "torsional cantilever." However, it is important to note that a "torsional cantilever" of the present invention may, when driven at a given frequency, vibrate in a flexural mode, a torsional mode or other vibrational modes. The use
10 of the term "torsional" is not intended to limit the vibrational modes of the cantilever of the present invention to torsional motion only.

[0029] Furthermore, in the present description, the term "axis of torsion" refers to an axis of the cantilever where
15 the cantilever is not displaced by torsional vibration when the cantilever is vibrated. That is, the cantilever does not move in the torsional mode. For a symmetrical cantilever, such as a rectangular cantilever, the axis of torsion is the center line of the cantilever arm
20 perpendicular to the base of the cantilever. However, for cantilevers in other geometries, the axis of torsion is not necessarily the center line of the cantilever arm and moreover, is not necessarily a straight line. The axis of torsion for a cantilever of any given geometry can be
25 determined, such as by use of a simulation software. In conventional cantilevers, the probe tip is always positioned on the axis of torsion of the cantilever arm.

[0030] Figure 2A is a perspective view of a cantilever according to one embodiment of the present invention.
30 Figure 2B is a top view of the cantilever of Figure 2A. Referring to Figures 2A and 2B, a torsional cantilever 100 is a rectangular cantilever and includes a cantilever arm 102 projecting from a base. A probe tip 106 is positioned

near the free end of cantilever arm 102. For torsional cantilever 100, the axis of torsion is the center line of cantilever arm 102, indicated by a dash-dot line 104 in Figures 2A and 2B. Probe tip 106 is an offset position
5 relative to the axis of torsion (line 104). Specifically, in the present embodiment, probe tip 106 is positioned a distance "d" from the axis of torsion. By placing probe tip 106 away from the axis of torsion, the probe tip will be displaced when the cantilever is vibrated in the torsional
10 mode. The torsional motion of the cantilever is then enhanced, resulting in the amplification of high frequency harmonics of the tip-sample interaction force.

[0031] The amount of offset displacement or the distance "d" can vary from a minimal displacement (near the axis of
15 torsion) to maximum displacement (near the edge of the cantilever arm). The exact amount of offset is selected based on design choice. In most cases, a minimal displacement of more than the normal process variations or alignment errors should be used to ensure that the probe tip
20 is displaced from the axis of torsion. For example, in one embodiment, the probe tip should be at least about 2 μ m from the axis of torsion. It is generally understood that the farther away the probe tip is displaced from the axis of torsion, the more torsional motion the probe tip will
25 experience. Thus, the probe tip can be placed near the axis of torsion for minimum torsional motion and placed near the edge of the cantilever arm to obtain maximum torsional motion.

[0032] Figure 3 illustrates the mode shape of the
30 torsional mode of cantilever 100. As can be seen from Figure 3, locations on the cantilever that are away from the torsion axis (center line in this case) exhibit larger displacement. If the tip offset distance is larger, tip-

sample forces will create a larger torque and hence result in a larger torsion angle and better excitation of torsional modes. This is advantageous in terms of signal improvement, however, the effect of torsional modes on the overall
5 cantilever dynamics will be more significant.

[0033] When cantilever 100 of the present invention is applied in a scanning force microscope, such as the tapping-mode AFM of Figure 1, the same deflection measurement technique can be used to detect the flexural movement as
10 well as the torsional movement of the cantilever. Figure 4 illustrates a split photodetector and a deflection measurement technique using the photodetector for detecting flexural and torsional movements. The split photodetector used in a SFM is usually divided into four quadrants Q1 to
15 Q4. The light spot resulted from the reflection of the laser light beam off the cantilever arm is shown as a circular spot about the center of the photodetector quadrants. The movement of the tip of the cantilever is detected by summing and subtracting of the light signals
20 detected in each of the quadrants. In the illustration in Figure 4, it is assumed that the flexural motion of the cantilever tip results in an up-down motion of the light spot and the torsional motion results in a left-right motion of the light spot. To measure the flexural deflection of
25 the cantilever tip, the signals in quadrants Q1 and Q2 are summed and the signals in quadrants Q3 and Q4 are summed. The difference of the two summed signals is then used to indicate flexural motion. To measure the torsional deflection of the cantilever, the signals in quadrants Q1
30 and Q3 are summed and the signals in quadrants Q2 and Q4 are summed. The difference of the two summed signals is then used to indicate torsional motion. In case of a misaligned

photodiode and cantilever the cross talk between the flexural and torsional signals has to be taken into account.

[0034] One advantage of the torsional cantilever of the present invention when applied in a scanning force microscope in an increase in imaging speed. When the torsional deflections are used in the feedback loop of the scanning force microscope, the torsional harmonics, being at higher frequencies, provide a faster response time for the imaging signals. Furthermore, the high frequency torsional harmonic signals can be advantageously applied to enable rapid detection of tip-sample engagement and disengagement.

[0035] In a conventional cantilever, the torsional vibration or torsional modes have higher resonant frequencies than the fundamental flexural modes. However, the torsional modes of the cantilever are not excited in a conventional cantilever. In accordance with the present invention, the torsional cantilever can be used to excite the torsional mode to enable detection of high frequency force components. When the torsional cantilever of the present invention is applied in a dynamic AFM operation, the torsional cantilever is oscillating in a flexural mode while the tip-sample interaction forces will excite torsional modes of the cantilever. The torsional modes are excited because the tip of the torsional cantilever is located offset from the axis of torsion. The offset placement of the probe tip allows tip-sample forces to generate torsion on the cantilever. Because the torsion arm (the width of the cantilever arm) is shorter than the length of the cantilever, a small tip displacement in the torsional mode will result in a relatively large angular deflection. Therefore, a laser beam reflected from the back of the cantilever can easily detect the torsional motion of the cantilever. Because the torsional modes of the cantilever

have high bandwidth, high frequency harmonics of the tip-sample forces will efficiently generate torsional vibrations.

[0036] The torsional cantilever of the present invention
5 can be configured in many shapes and geometry depending on the desired application. The salient feature of the torsional cantilever of the present invention is the offset placement of the probe tip from the axis of torsion. The probe tip can be displaced on either side of the axis of
10 torsion. Figure 5 is a top view of a cantilever according to a first alternate embodiment of the present invention. Referring to Figure 5, a torsional cantilever 120 is configured as a rectangular cantilever with an enlarged free end. A probe tip 126 is positioned at an offset
15 displacement from the axis of torsion 124 of the cantilever arm. In one implementation, cantilever 120 is able to realize a first torsional resonance frequency that is 16.3 times the fundamental flexural resonance frequency. The wider free end of cantilever 120 has the effect of tuning
20 the torsional resonance frequency of the cantilever as will be described in more detail below.

[0037] Figures 6 and 7 are spectrums of the flexural and torsional vibrations, respectively, of cantilever 120 tapping on a sample surface at the fundamental flexural
25 resonance frequency. From a comparison of the vibration spectrum of the flexural mode (Figure 6) and the vibration spectrum of the torsional mode (Figure 7), it can be observed that more high harmonic force components are excited in the torsional mode with better signal to noise
30 ratio. Thus, more information regarding the tip-sample interaction can be retrieved from the torsional vibration spectrum.

[0038] Figures 8-10 illustrate three other alternate embodiments of the torsional cantilever of the present invention. One of ordinary skill in the art, upon being apprised of the present description, would appreciate that the torsional cantilever of the present invention can be implemented using various cantilever configurations and geometries. Referring to Figure 8, a torsional cantilever 140 is formed as a rectangular cantilever with a tapered free end. A probe tip 146 is positioned offset from the axis of torsion (line 144). Referring to Figure 9, a torsional cantilever 160 is configured as a rectangular cantilever including two arms 162A and 162B separated by an opening 168. The free end of cantilever 160 is also tapered. A probe tip 166 is positioned at an offset location from the axis of torsion (line 164). Finally, referring to Figure 10, a torsional cantilever 180 is formed as a triangular cantilever including arms 182A and 182B. A probe tip 186 is positioned at an offset location from the axis of torsion (line 184).

[0039] The torsional cantilever of the present invention has many applications in imaging and in material analysis. In one application, the torsional harmonics (both phase and amplitude) of the torsional cantilever are measured for generating images of the sample surface. In another application, the torsional cantilever is applied to generate a large number of vibration harmonics. When most or all of the harmonic force components are measured, the harmonic force components can be added in the time domain to reconstruct the time-resolved waveform of the tip-sample forces. It is well understood that when all the harmonic force components are added together a force diagram of the tip-sample interaction is constructed. More specifically, a weighted sum of the harmonic force components in the time

domain is used to reconstruct the time-resolved waveform of the tip-sample forces. The weighted sum of the harmonic force components is calculated by multiplying each harmonic amplitude by a factor before summation where the factor is the frequency response of the cantilever. A weighted sum is used because the same force amplitude at two different frequencies result in different vibration amplitudes. The difference in vibration amplitudes is taken into consideration by the use of the weighted sum. The torsional cantilever of the present invention enables the generation of torsional harmonics with enhanced amplitude so that measurement of the harmonics can be readily made. Thus, the torsional cantilever of the present invention enables the measurement of the force/distance relations of the tip-sample interaction.

[0040] According to another aspect of the present invention, a torsional cantilever has a torsional resonance frequency that matches an integer multiple of the fundamental flexural resonance frequency of the cantilever when the cantilever is driven at a driving frequency. Such a torsional cantilever, referred herein as a "torsional harmonic cantilever", has one of its harmonics coincided with the torsional resonance of the cantilever. In this manner, the torsional motion of the torsional harmonic cantilever at that harmonic frequency will be largely enhanced by the corresponding torsional resonance. The ratio of the torsional resonance frequency to the fundamental flexural resonance frequency of the torsional harmonic cantilever can be tuned by selecting appropriate cantilever geometry since the geometry of the cantilever determines the resonance frequencies of the cantilever. The torsional harmonic cantilever of the present invention can provide improvement in imaging by using the higher order

harmonics as the imaging signals. While the tuned resonance frequency will have a high signal to noise ratio, all other harmonics of the cantilever vibration will still have good signal to noise ratio due to the torsional motion.

5 [0041] Figure 11 is a top view of a torsional harmonic cantilever according to one embodiment of the present invention. Referring to Figure 11, a torsional harmonic cantilever 200 includes a cantilever arm formed by a first arm portion 202A and a second arm portion 202B. The first
10 and second arm portions are separated by an opening 208. A probe tip 206 is located at the free end of the cantilever arm and is positioned at an offset displacement from the axis of torsion of the cantilever. Cantilever 200 includes a free end that has an asymmetrical shape where one side of
15 the free end is tapered. By incorporating two separated arm portions in cantilever 200, each arm portion can bend more easily so that torsional resonance frequencies are lowered. One has to choose proper dimensions for the arms to tune the ratio of the torsional resonance frequency and fundamental
20 flexural resonance frequency to an integer..

[0042] By using an offset tip placement, torsional harmonic cantilever 200 can enhance torsional motion to enable detection of high frequency force components of the tip-sample interaction. In one implementation, cantilever
25 200 is able to realize a first torsional resonance frequency that is 9 times the fundamental flexural resonance frequency.

[0043] In cantilever 200, the tuning of the torsional resonance frequency to match an integer multiple of the
30 fundamental flexural resonance frequency of the cantilever can be carried out by varying the width of arm portions 202A and 202B or by varying the size of opening 208. The shape

of the free end can also be configured to tune the resonance frequency. Figure 12 is the torsional vibration spectrum of torsional harmonic cantilever 200 while the cantilever is being tapped on a surface at the fundamental resonance frequency. Referring to Figure 12, the first peak in the vibration spectrum is at the fundamental resonance frequency and the peak at 400 kHz is the torsional resonance frequency. The torsional resonance frequency at 400 kHz is at the 9th harmonic of the fundamental resonance frequency and the signal to noise is more than 40 dB. The vibration spectrum of Figure 12 illustrates how torsional harmonic cantilever 200 can be tuned to have a torsional resonance frequency that is 9 times the fundamental flexural resonance frequency.

[0044] Figure 13 illustrates the mode shape of the torsional vibration of the torsional harmonic cantilever of Figure 11. The mode shape confirms that by placing the probe tip near the edge of the cantilever arm, the tip will experience large displacement in torsional modes, providing enhanced torsional signals.

[0045] Torsional cantilever 120 of Figure 5 represents another configuration for a torsional harmonic cantilever. The torsional cantilever of Figure 5 illustrates how the fundamental resonance frequency can be altered to tune the ratio of the torsional resonance frequency to the fundamental resonance frequency. Returning to Figure 5, the free end of cantilever 120 is made wider than the rest of the cantilever arm. Because the free end is a highly displaced part of the fundamental resonance frequency, by making the free end wider, mass is added to the fundamental resonance frequency which has the effect of lowering the resonance frequency of the fundamental. The mass addition does not change the torsional resonance frequency

appreciably but the fundamental frequency is lowered so that the ratio of the two is tuned.

[0046] In the above description, the use of the term "torsional harmonic cantilever" is not intended to limit the vibrational modes of the cantilever of the present invention to torsional motion only. As described above, the "torsional harmonic cantilever" of the present invention may, when driven at a given frequency, vibrate in a flexural mode, a torsional mode or other vibrational modes.

10 [0047] Furthermore, in the torsional harmonic cantilever of the present invention, the torsional resonance frequency and the fundamental flexural resonance frequency have an integer ratio or a ratio slightly below or slightly above an integer ratio, such as within 2% of the integer ratio.

15 Thus, the integer ratio includes whole numbers and fractional numbers slightly greater than or less than the nearest whole numbers so that when the cantilever is driven at a driving frequency at or slightly below or slightly above the fundamental resonance frequency, the torsional

20 resonance frequency is an integer multiple of the driving frequency.

[0048] The tuning of the ratio of the torsional resonance frequency to the fundamental flexural resonance frequency of the torsional harmonic cantilever to an integer value or

25 near integer value can be accomplished in primarily two ways. First, the tuning can be accomplished by tuning the fundamental flexural resonance frequency to be an integer divisible of the resonance frequency of the selected torsional resonance frequency. Second, the tuning can be

30 accomplished by tuning the resonance frequency of the selected torsional mode to be an integer multiple of the fundamental flexural resonance frequency. Alternately, both

tuning methods can be applied at the same time to tune the ratio to the selected torsional resonance frequency to be an integer multiple of the fundamental flexural resonance frequency.

5 [0049] Tuning the fundamental frequency of the torsional harmonic cantilever to be an integer divisible of the resonance frequency of the selected torsional resonance frequency can be accomplished by incorporating geometric features in the cantilever that have dominant effects on
10 changing the fundamental flexural resonance frequency as compared to the resonance frequency of the torsional modes. For instance, increasing or decreasing the length of the cantilever by adding or removing mass to the free end of the cantilever will corresponding increase or decrease the
15 frequency ratio.

[0050] Alternately, when the cantilever has a rectangular shape or close to a rectangular shape with or without a tapered end, the length to width ratio of the cantilever arm can be adjusted to alter the fundamental flexural resonance
20 frequency. The higher the length to width ratio, the higher the ratio of the torsional to fundamental frequencies. Selecting correct values of length and width will tune the frequency ratio to an integer value or near integer value.

[0051] The fundamental resonance frequency can also be
25 tuned by increasing or decreasing the effective width or thickness at a highly displaced region of the fundamental mode, which has the effect of decreasing or increasing the fundamental resonance frequency. Typically, this mass modification is applied towards the free end of the
30 cantilever. By decreasing or increasing the fundamental resonance frequency, the ratio of the torsional to

fundamental frequencies will correspondingly increase or decrease.

[0052] Finally, the frequency ratio can also be tuned by increasing or decreasing the effective width or thickness at
5 a high mechanical stress region that has the effect of decreasing or increasing the resonance frequency ratio. Typically, this mass modification is applied towards the base of the cantilever.

[0053] Tuning the resonance frequency of the selected
10 torsional mode to be an integer multiple of the fundamental flexural resonance frequency can be accomplished by incorporating geometric features in the cantilever that have dominant effects on changing the resonance frequency of the torsional modes as compared to the fundamental flexural
15 resonance frequency. In a cantilever, there are many torsional vibrational modes. In general, the first few (2-3) modes are of interest.

[0054] First, the resonance frequency of a torsional mode can be tuned by forming arm portions with openings in the
20 body of the cantilever while maintaining the effective width of the cantilever without the openings. One exemplary embodiment of such a torsional harmonic cantilever is shown in Figure 11. Referring to Figure 11, the arm portions and the openings can be characterized by the location of the
25 opening(s) along the body of the cantilever, the separation ("a") of the arms and the extension ("b") of the opening(s). Proper tuning can be achieved by adjusting the location and the extension of the opening and the separation of the arms, such as by use of a simulation tool to find the optimum
30 values of the separation and extension lengths. In general, providing arm portions with openings in the body of the cantilever will lower the ratio of the resonance

frequencies. The amount that the ratio is lowered is proportional to the extension of the opening.

[0055] Alternately, increasing the separation ("a") of the arms will reduce the frequency ratio if the arms are
5 located at a high angular displacement region in that particular torsional mode. Also, the width of the individual arms can also be increased to tune the resonance frequency of the torsional mode, mainly by leading to an increase in the effective width of the cantilever.

10 [0056] In Figure 11, torsional harmonic cantilever has two arm portions in parallel. This geometric configuration is illustrative only and is not intended to be limiting. A torsional harmonic cantilever of the present invention can be provided with multiple arm portions. Furthermore, the
15 arm portions do not have to be parallel, that is, the arm portions can be anti-parallel. For instance, Figure 10 illustrates a V-shaped torsional harmonic cantilever including two arm portions.

[0057] The above detailed descriptions are provided to
20 illustrate specific embodiments of the present invention and are not intended to be limiting. Numerous modifications and variations within the scope of the present invention are possible. The present invention is defined by the appended claims.

CLAIMS

We claim:

1. A cantilever for the use in atomic force microscopy comprising:
 - 5 a cantilever arm having a fixed end being attached to a base member and a free end, the cantilever arm having a first shape and an axis of torsion associated with the first shape; and
 - a probe tip projecting from the cantilever arm
 - 10 near the free end, the probe tip being positioned in an offset displacement from the axis of torsion.
2. The cantilever of claim 1, wherein the probe tip is positioned at least about 2 μ m from the axis of torsion.
3. The cantilever of claim 1, wherein the probe tip
- 15 is positioned away from the axis of torsion and near an outside edge of the cantilever arm.
4. The cantilever of claim 1, wherein the cantilever arm has a first shape selected to tune a torsional resonance frequency of a selected torsional mode or the fundamental
- 20 flexural resonance frequency of the fundamental mode so that the torsional resonance frequency and the fundamental flexural resonance frequency has an integer ratio.
5. The cantilever of claim 4, wherein the integer ratio comprises whole numbers and fractional numbers
- 25 slightly greater than or less than the nearest whole numbers so that when the cantilever is driven at a driving frequency at or slightly below or slightly above the fundamental resonance frequency, the torsional resonance frequency is an integer multiple of the driving frequency.

6. The cantilever of claim 5, wherein the integer ratio comprises whole numbers and fractional numbers within 2.0% of the nearest whole numbers.

7. The cantilever of claim 1, wherein the cantilever arm comprises a first arm portion and a second arm portion separated by an opening, the opening extending at least partially between the fixed end and the free end.

8. The cantilever of claim 7, wherein the cantilever arm has a first shape and the first and second arm portions each has a width selected to tune a torsional resonance frequency to an integer multiple of the fundamental flexural resonance frequency of the cantilever.

9. The cantilever of claim 7, wherein the opening of the cantilever arm has an extension and provides a separation between the first and second arm portions, the extension and the separation selected to tune a torsional resonance frequency to an integer multiple of the fundamental flexural resonance frequency of the cantilever.

10. The cantilever of claim 4, wherein the cantilever arm comprises a plurality of arm portions separated by one or more corresponding openings, each opening being positioned at a location between the fixed end and the free end and having an extension between the fixed end and the free end, each opening providing a separation for a pair of adjacent arm portions.

11. The cantilever of claim 10, the location of each opening or the extension of each opening or the separation between each pair of adjacent arm portion is adjusted to tune the torsional resonance frequency to an integer multiple of the fundamental flexural resonance frequency of the cantilever.

12. The cantilever of claim 10, wherein the plurality of arm portions are parallel to each other.

13. The cantilever of claim 10, wherein the plurality of arm portions are anti-parallel to each other.

5 14. The cantilever of claim 10, wherein the location of the one or more openings is at a high angular displacement region of the selected torsional mode for tuning the torsional resonance frequency.

10 15. The cantilever of claim 4, wherein the cantilever arm has a first length selected to tune the fundamental flexural resonance frequency of the cantilever to a value that is an integer divisible of the selected torsional mode.

15 16. The cantilever of claim 4, wherein the cantilever arm comprises a substantially rectangular shape and has a length to width ratio selected to tune the fundamental flexural resonance frequency of the cantilever to a value that is an integer divisible of the selected torsional mode.

20 17. The cantilever of claim 4, wherein the cantilever arm has an effective width or an effective thickness at a highly displaced region of the fundamental mode selected to tune the fundamental flexural resonance frequency of the cantilever to a value that is an integer divisible of the selected torsional mode.

25 18. The cantilever of claim 4, wherein the cantilever arm has an effective width or an effective thickness at a high mechanical stress region of the fundamental mode selected to tune the fundamental flexural resonance frequency of the cantilever to a value that is an integer divisible of the selected torsional mode.

19. The cantilever of claim 4, wherein the cantilever arm comprises a substantially rectangular shape with an enlarged free end for tuning the fundamental flexural resonance frequency of the cantilever to a value that is an integer divisible of the selected torsional mode.

20. A method for measuring high frequency force of interaction between a tip of a cantilever and a sample, comprising:

providing a cantilever having a cantilever arm and a probe tip formed on a free end of the cantilever arm, the cantilever arm having a first shape and an axis of torsion associated with the first shape, the probe tip being positioned in an offset displacement from the axis of torsion;

vibrating the cantilever at or near the fundamental flexural resonance frequency with a predetermined oscillation amplitude;

bringing the cantilever to the vicinity of the sample;

tapping the surface of the sample repeatedly using the probe tip; and

detecting changes in the amplitude or the phase of a high frequency vibration harmonic of the cantilever as the cantilever is deflected in response to features on the surface of the sample.

21. The method of claim 20, wherein detecting changes in the amplitude or the phase of a high frequency vibration harmonic of the cantilever comprises detecting changes in the amplitude or the phase of a high frequency torsional vibration harmonic of the cantilever.

22. The method of claim 21, wherein detecting changes in the amplitude or the phase of a high frequency torsional vibration harmonic of the cantilever comprises:

providing a photodetector divided into four
5 quadrants;
detecting flexural vibration of the cantilever using the difference between the sum of the signals from a first quadrant and a second quadrant and the sum of the signals from a third quadrant and a fourth
10 quadrant; and
detecting torsional vibration harmonic of the cantilever using the difference between the sum of the signals from the first quadrant and the third quadrant and the sum of the signals from the second quadrant and
15 the fourth quadrant.

23. The method of claim 20, wherein detecting changes in the amplitude or the phase of a high frequency vibration harmonic of the cantilever comprises detecting changes in the amplitude or the phase of a high frequency flexural
20 vibration harmonic of the cantilever.

24. The method of claim 20, wherein providing a cantilever having a cantilever arm and a probe tip comprises:

providing a cantilever having a cantilever arm and
25 a probe tip formed on a free end of the cantilever arm, the cantilever arm having a first shape and an axis of torsion associated with the first shape, the probe tip being positioned in an offset displacement from the axis of torsion, wherein the first shape is selected to
30 tune a torsional resonance frequency or the fundamental flexural resonance frequency of the fundamental mode of the cantilever so that the torsional resonance

frequency and the fundamental flexural resonance frequency has an integer ratio.

25. The method of claim 24, further comprising:

5 detecting changes in the amplitude or the phase at the torsional resonance frequency as the cantilever is deflected in response to features on the surface of the sample.

26. A method for measuring high frequency force of interaction between a tip of a cantilever and a sample,
10 comprising:

providing a cantilever having a cantilever arm and a probe tip formed on a free end of the cantilever arm, the cantilever arm having a first shape and an axis of torsion associated with the first shape, the probe tip
15 being positioned in an offset displacement from the axis of torsion;

vibrating the cantilever at or near the fundamental flexural resonance frequency with a predetermined oscillation amplitude;

20 bringing the cantilever to the vicinity of the sample;

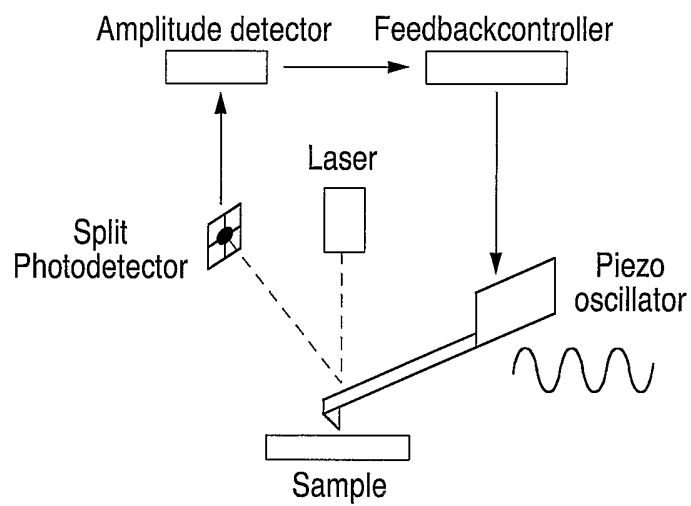
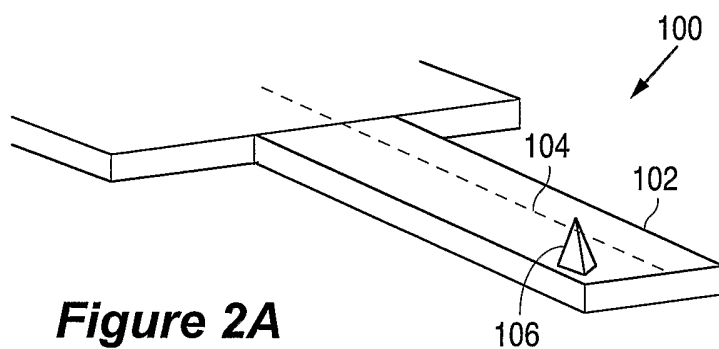
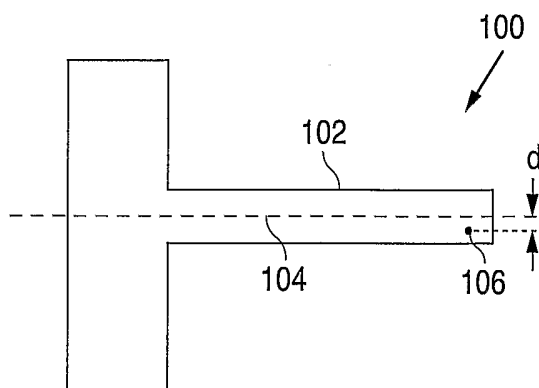
tapping the surface of the sample repeatedly using the probe tip;

25 measuring torsional vibration harmonics of the cantilever motion as the cantilever is deflected in response to features on the surface of the sample; and reconstructing the time-resolved waveform of the tip-sample forces using the measured torsional vibration harmonics.

30 27. The method of claim 26, wherein the reconstructing the time-resolved waveform of the tip-sample forces using the measured torsional vibration harmonics comprises summing

the measured torsional vibration harmonics in the time domain using a weighted sum to reconstruct the time-resolved waveform of the tip-sample forces.

1/6

**Figure 1****Figure 2A****Figure 2B**

2/6

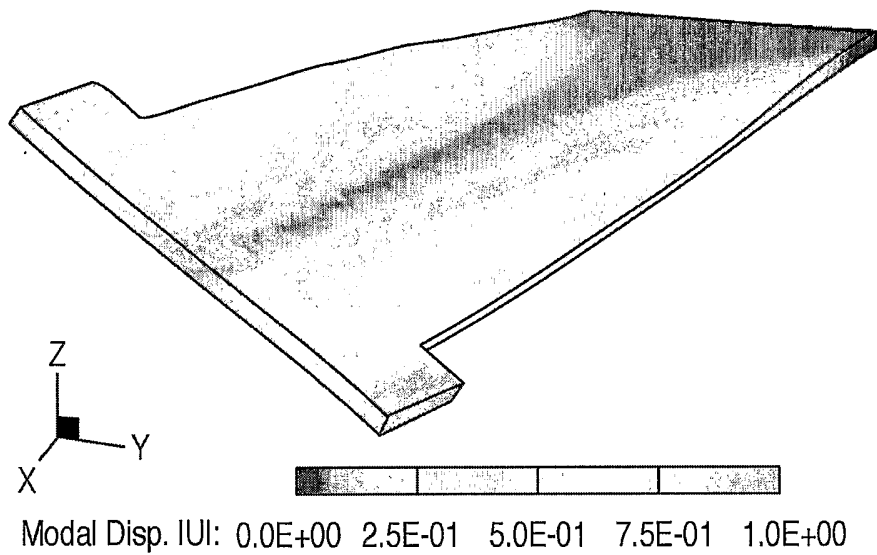


Figure 3

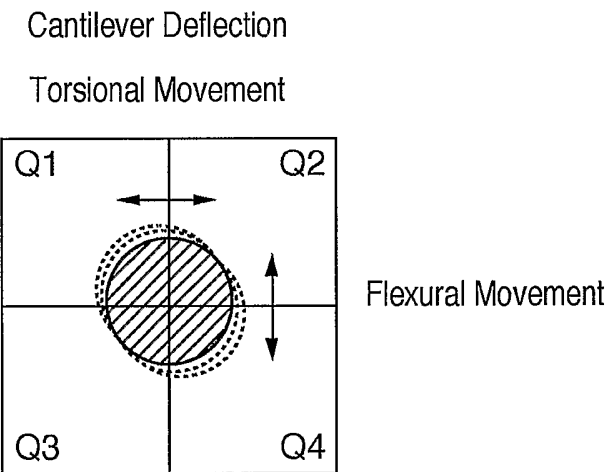


Figure 4

3/6

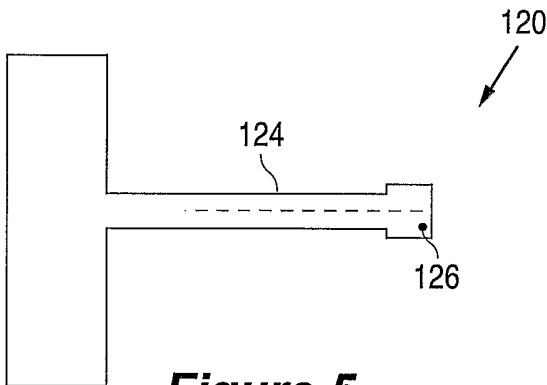


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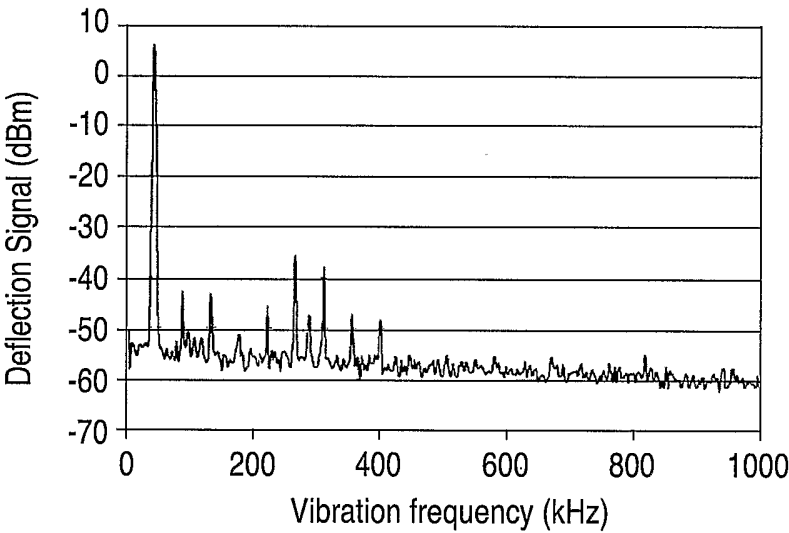


Figure 6

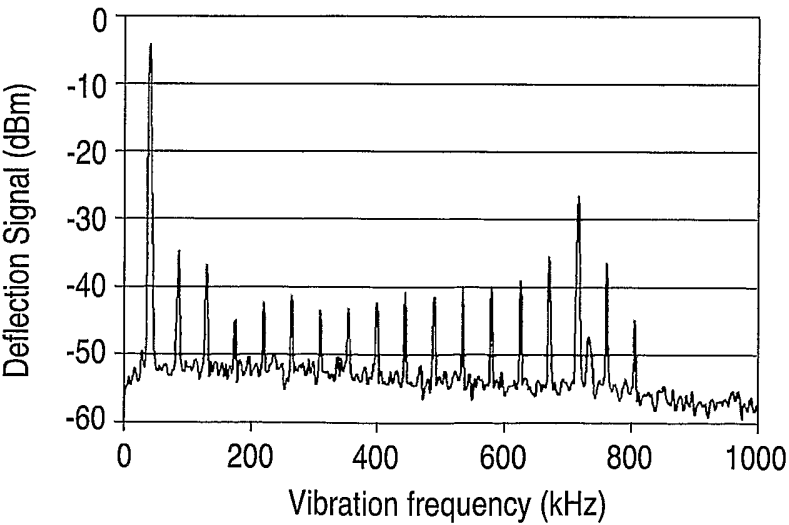


Figure 7

4/6

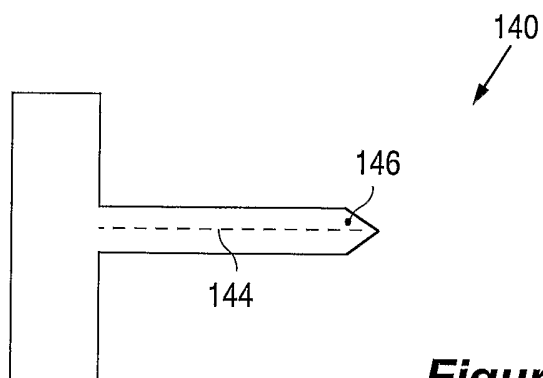
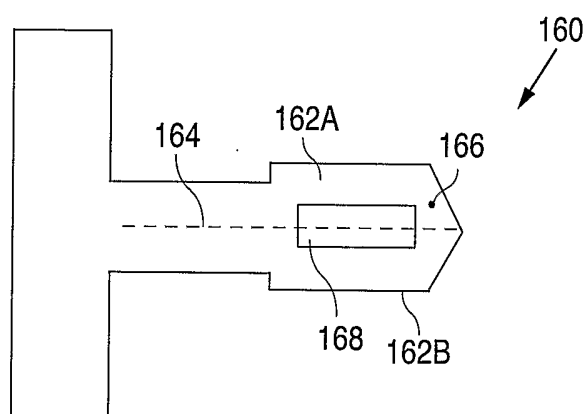
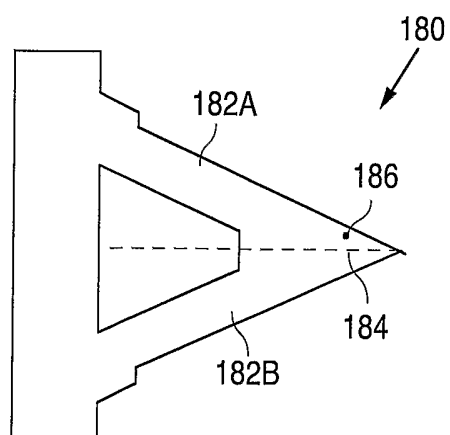
**Figure 8****Figure 9****Figure 10**

Figure 11

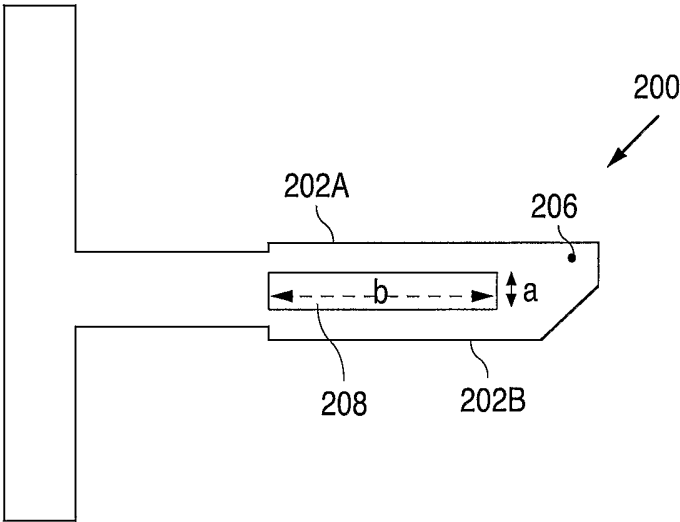
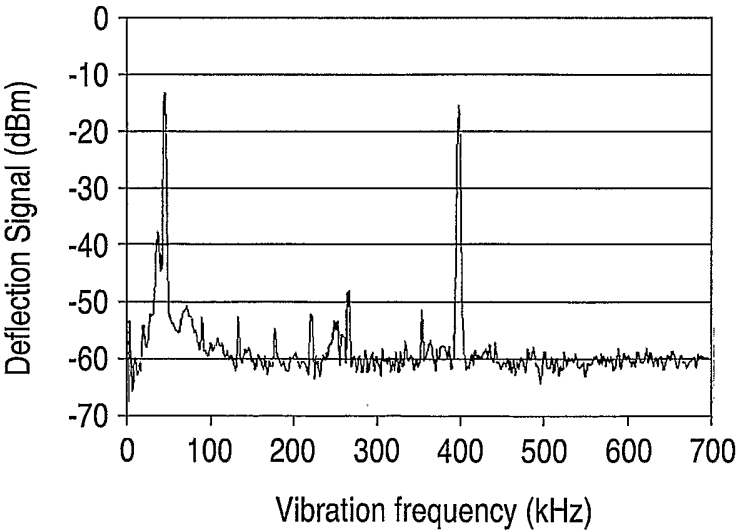
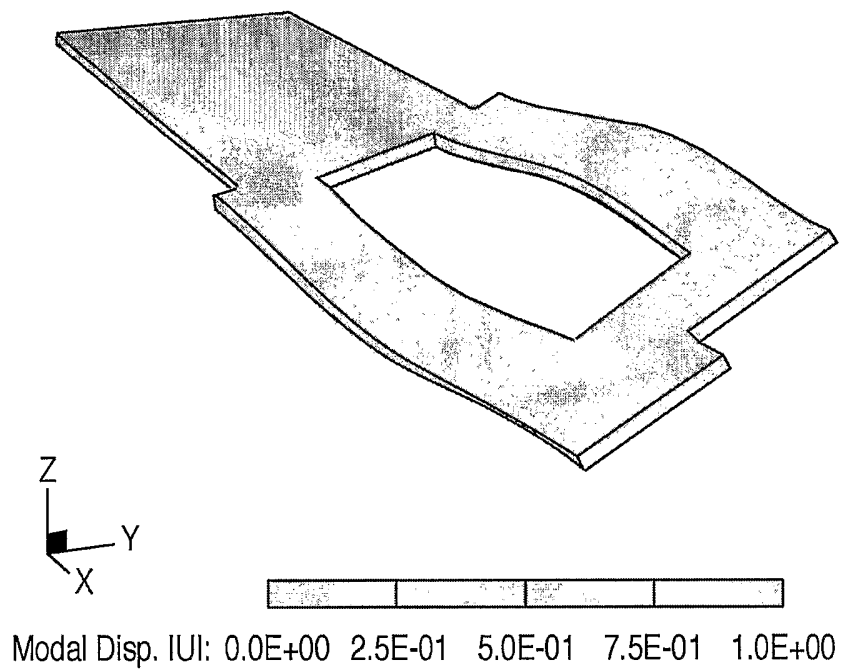


Figure 12



6/6

**Figure 13**

INTERNATIONAL SEARCH REPORT

Int. I Application No
PCT/US2005/024098

A. CLASSIFICATION OF SUBJECT MATTER
IPC 7 G12B21/02 G12B21/08

According to International Patent Classification (IPC) or to both national classification and IPC

B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)
IPC 7 G12B G01B

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data, PAJ, INSPEC, COMPENDEX, BIOSIS, EMBASE

C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category °	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	WO 00/46569 A (XIDEX CORPORATION) 10 August 2000 (2000-08-10) figures 5-8,11-19,22,23 page 8, line 27 - page 9, line 17 page 12, line 23 - page 15, line 16 page 17, line 27 - page 18, line 23	1-27
A	US 5 646 339 A (BAYER ET AL) 8 July 1997 (1997-07-08) figures 1-5 column 3, line 43 - column 6, line 24	1-27
A	WO 2004/005845 A (VEECO INSTRUMENTS, INC) 15 January 2004 (2004-01-15) figures 12-15 page 23, line 23 - page 25, line 17 ----- -/--	1-27

☒ Further documents are listed in the continuation of box C.

☒ Patent family members are listed in annex.

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Date of the actual completion of the international search

13 October 2005

Date of mailing of the international search report

26/10/2005

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INTERNATIONAL SEARCH REPORT

International Application No
PCT/US2005/024098

C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	<p>US 6 079 255 A (BINNIG ET AL) 27 June 2000 (2000-06-27) figures 1-7 column 7, line 9 - column 9, line 54 -----</p>	1-27

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